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Substitute for form 1449B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	09/605,520
		Filing Date	06/27/00
		First Named Inventor	Marc A. Unger
		Group Art Unit	3746 — 1763
		Examiner Name	Charles Frey — Olsen
Sheet 1 of 2	Attorney Docket Number	20174-000230US	

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
Heu	4	Jung et al., "Chemical and Physical Interactions at Metal/Self-Assembled Organic Monolayer Interfaces," <u>Crit. Rev. Solid State Material Sciences</u> , 19(1):2-10 (1994) XP000955639	
Fre	5	Maluf, N., <i>An Introduction to Microelectromechanical Systems Engineering</i> , Artech House Publishers, Boston London pages 42-45.	
Heu	6	Qin et al., "Photolithography with transparent reflective photomasks," <u>J. Vac. Science and Technology</u> , 16(1):98-103 (1998) XP00213356	
Heu	7	Schueller et al., "Fabrication of glassy carbon microstructures by soft lithography," <u>Sensors and Actuators A</u> , 72(2):125-139 (1999) XP004155654	
Heu	8	Xia et al., "Micromodeling of Polymers in Capillaries: Applications in Microfabrication," <u>Chemistry of Materials</u> , 8(7):1558-1567 (1996) XP000626885	

Examiner Signature	<i>Heu</i>	Date Considered	3/22/03
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\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Substitute for form 1449A/PTO		<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		Application Number	09/605,520
		Filing Date	06/27/00
		First Named Inventor	Marc A. Unger
		Group Art Unit	3740 1763
		Examiner Name	Charles Freay O/Sen
Sheet 1 of 2	Attorney Docket Number	20174-000230US	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
ACW	1	6,174,365	B1	Sanjoh	01-16-2001	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>3</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
ACW	2	EP	829 360	A2		03-18-1998		
Ans	3	EP	592 094	A2		04-13-1994		

Examiner Signature	<i>ACW - Olsen</i>	Date Considered	3/22/03
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